



PATENT

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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of

Michael J. Scaggs

Application No.: 09/733,874

Filed: December 8, 2000

For: 157 NM LASER SYSTEM AND  
METHOD FOR MULTI-LAYER  
SEMICONDUCTOR FAILURE  
ANALYSIS

Confirmation No.: 3133

Group Art Unit: 2815

Examiner: Jose R. Diaz

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